Doc code: IDS Doc description: Information Disclosure Statement (IDS) Filed

PTO/SB/08a (01-10)

Approved for use through 07/31/2012. OMB 0651-0031

Mation Disclosure Statement (IDS) Filed

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10748523		
	Filing Date		2003-12-30		
	First Named Inventor	Micha	nel Chiviendacz		
	Art Unit		2436		
(Not for Submission under 67 of K 1.00)	Examiner Name	Fikrer	mariam A. Yalew		
	Attorney Docket Number		10500.03.0716		

U.S.PATENTS							Remove		
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	of sited Document Relevan		Columns,Lines where nt Passages or Relevant Appear		
	1								
If you wis	h to add a	additional U.S. Paten	t citatio	n information pl	ease click the Add button.		Add		
			U.S.P	ATENT APPLI	CATION PUBLICATIONS		Remove		
Examiner Initial*	Cite No	Publication Number	Kind Code ¹	Publication Date	Name of Patentee or Applicant of cited Document	Columns,Lines where nt Passages or Relevant Appear			
	1	20030009670	A1	2003-01-09	Rhoads				
	2	20050097320	A1	2005-05-05	Golan				
	3	20030154406	A1	2003-08-14	Honarvar et al.				
	4	20030233546	A1	2003-12-18	Blom				
	5	20040223619	A1	2004-11-11	Jablon				

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Not for submission under 37 CFR 1.99)

Application Number		10748523		
Filing Date		2003-12-30		
First Named Inventor	Micha	nel Chiviendacz		
Art Unit		2436		
Examiner Name	Fikremariam A. Yalew			
Attorney Docket Number		10500.03.0716		

	6		20050050328	A1	2005-03	-03	Mizrah				
If you wish to add additional U.S. Published Application citation information please click the Add button. Add											
FOREIGN PATENT DOCUMENTS Remove											
Examiner Initial*	Cite No	ı	reign Document mber³	Country Code ²		Kind Code ⁴	Publication Date	Name of Patentee Applicant of cited Document	e or	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear	T5
	1	02/ ⁻	17556	WO			2002-02-28	CMX Technologies			
	2	117	6489	EP		A1	2002-01-30	Dew Engineering ar Development Limite			
If you wisl	h to ac	dd a	dditional Foreign Pa	atent Do	cument	citation	information pl	ease click the Add	button	Add	
			_	NON	I-PATEN	NT LITE	RATURE DO	CUMENTS		Remove	
Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book magazine journal serial symposium catalog etc) date pages(s) volume issue number(s)								T 5	
	1	Supplementary EP Search Report; EP Application No. 04802268.5; dated August 4, 2010.									
If you wish to add additional non-patent literature document citation information please click the Add button Add											
EXAMINER SIGNATURE											
Examiner	Signa	ture						Date Conside	red		
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.											
¹ See Kind Codes of USPTO Patent Documents at www.USPTO.GOV or MPEP 901.04. ² Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). ³ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁴ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁵ Applicant is to place a check mark here if English language translation is attached.											